

NEW

NANOLITHOGRAPHY

eLiNE plus

Discover Nanoengineering beyond Electron Beam Lithography

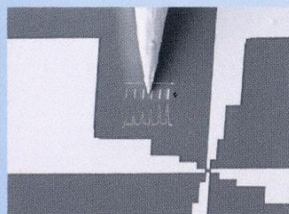
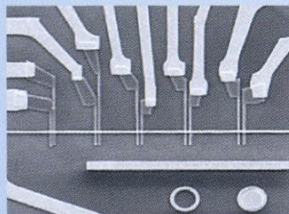
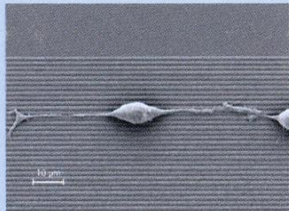
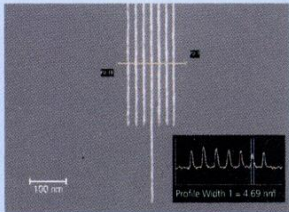


What's new ?

- Nanoprofilometry: The new *NanoSense* option adds a 3rd dimension to conventional secondary electron surface image information

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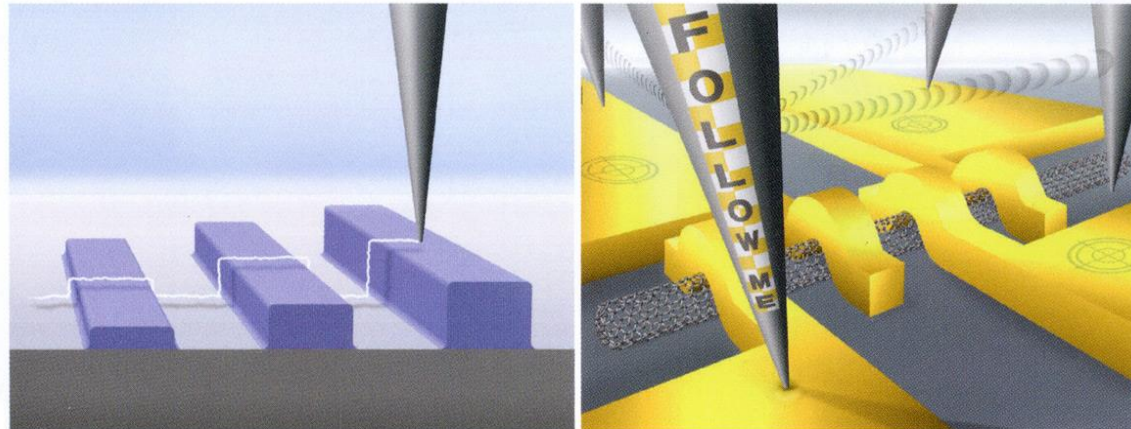
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The new e_LiNE *plus*: Most integrated, most versatile, most potential for pushing the limits



NanoSense used for Nanoprofilometry of EBID-Deposits

NanoSense used for "scouting": Enabling automated nanoprobing

System improvements:

The new *NanoSense* option adds a 3rd dimension to conventional secondary electron surface image information. A surface sensitive distance sensor is fit to one of four optional nanomanipulators for nanoprofilometry and scouting, the latter enabling very efficient automated nanoprobing.